

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: Customer Number: 20277

Shinji KISHIMURA, et al.

: Confirmation Number: 8700

Serial No.: 10/034,366

: Group Art Unit: 1756

Filed: January 03, 2002

: Examiner: DABORAH CHACKO DAVIS

For: PATTERN FORMATION MATERIAL AND PATTERN FORMATION METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
SEP 02 2003
GROUP 1700

Sir:

Noting the Office Action of August 1, 2003 wherein restriction has been required, Applicant(s) hereby elect Group II (claims 6-25, drawn to a pattern formation method) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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Date: August 28, 2003